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PATENT
90065.99R272 (17732.6323)
Response Under 37 CFR 1.111

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicant:	Jifa Hao, et al.)
Serial No.:	09/654,845)
Filed:	September 01, 2000)
Title:	POWER SEMICONDUCTOR DEVICE WITH HIGH AVALANCHE CAPABILITY AND PROCESS FOR FORMING SAME) Examiner: Ori Nadav Art Unit: 2811

RESPONSE UNDER 37 CFR 1.116

MS: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed October 11, 2005, Applicants hereby submit the following Amendment and Remarks.

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